

(19)



Europäisches Patentamt
European Patent Office
Office européen des brevets



(11)

EP 1 557 721 A2

(12)

EUROPEAN PATENT APPLICATION

(43) Date of publication:

27.07.2005 Bulletin 2005/30

(51) Int Cl.7: **G03F 7/20**

(21) Application number: **05000989.3**

(22) Date of filing: **19.01.2005**

(84) Designated Contracting States:

**AT BE BG CH CY CZ DE DK EE ES FI FR GB GR
HU IE IS IT LI LT LU MC NL PL PT RO SE SI SK TR**
Designated Extension States:
AL BA HR LV MK YU

- **Budhlall, Bridgette Maria**
Bethlehem, PA 18018 (US)
- **Parris, Gene Everad**
Coopersburg, PA 18036 (US)
- **Barber, Leslie Cox**
Cave Creek, AZ 85331 (US)

(30) Priority: **23.01.2004 US 764227**

07.01.2005 US 30132

(74) Representative: **Tepel, Susanne, Dr. et al**
Schwabe, Sandmalr, Marx
Patentanwälte
Stuntzstrasse 16
81677 München (DE)

(71) Applicant: **AIR PRODUCTS AND CHEMICALS,
INC.**

Allentown, PA 18195-1501 (US)

(72) Inventors:

- **Zhang, Peng**
Quakertown, PA 18951 (US)

(54) **Immersion lithography fluids**

(57) Suitable additives that may be added into immersion fluids, immersion fluids comprising at least one carrier medium selected from an aqueous fluid, a non-aqueous fluid, and mixtures thereof, and immersions fluids comprising at least one carrier medium and at least

one additive useful for performing immersion lithography at an operating wavelength ranging from 140 nm to 365 nm are disclosed herein.

EP 1 557 721 A2

Description

CROSS-REFERENCE TO RELATED APPLICATIONS

- 5 [0001] This application is a continuation-in-part of U.S. Patent Application No. 10/764,227, filed 23 January 2004, the disclosure of which is incorporated herein by reference in its entirety.

BACKGROUND

- 10 [0002] Immersion lithography may offer better resolution enhancement and higher numerical apertures at a given exposure wavelength over conventional projection lithography. For example, immersion lithography could extend lithography at the 193 nm wavelength down to the 45 nm node and below thereby providing an alternative to 157 nm exposure wavelengths, extreme ultraviolet (EUV), and other potential technologies.

- 15 [0003] The minimum feature width (W) that may be printed with an optical lithography system is determined by the Rayleigh equation: $W = (k_1 \lambda) / (NA)$ where k_1 is the resolution factor, λ is the wavelength of the exposing radiation and NA is the numerical aperture. Numerical aperture (NA) is determined using the equation: $NA = n \sin \alpha$ where n is the index of refraction of the medium surrounding the lens and α is the acceptance angle of the lens. The physical limit to NA for exposure systems using air as a medium between the lens and the wafer is 1. Air is the worst medium because its index of refraction may cause a relatively high amount of bending when light leaves the glass. Since the index of refraction for water and glass is approximately 1.44 and 1.52 respectively, far less bending occurs thereby providing a sharper and deeper focus.

- 20 [0004] In immersion lithography, the space between the lens and the substrate is filled with a liquid, referred to herein as an immersion fluid, that has a refractive index greater than 1. The immersion fluid should preferably exhibit a low optical absorption at the operating wavelength such as, for example 193 nm and 157 nm, be compatible with the photoresist and the lens material, be uniform and be non-contaminating. A preferred immersion fluid for 193nm immersion lithography is ultra pure water. Ultra pure water has an index of refraction of approximately 1.44, exhibits absorption of less than 5 % at working distances of up to 6 mm, is compatible with photoresist and lens, and is non-contaminating in its ultra pure form. Applying the Rayleigh equation using $n=1.44$ and assuming $\sin \alpha$ can reach 0.93, the feature width for 193 nm could reach a theoretical minimum resolution of 36 nm. Still other immersion fluids that have been considered for 15nm immersion lithography are KRYTOX™ and perfluoropolyether (PFPE).

- 30 [0005] To date, immersion lithography has not been widely implemented in commercial semiconductor processing partly because improvements in resolution by conventional methods have been possible, but also partly because of practical limitations in implementing immersion lithography. The wafer stage of a typical 193 nm exposure tool steps from location to location across the wafer scanning the reticle image for each field. In order to achieve high throughput, the stage should accelerate rapidly, move accurately to the next field location, settle, scan the image, and then step to the next location within a short time interval. The immersion fluid is typically introduced between the lens and the resist surface of the substrate using a jet stream of the immersion fluid. The space between the lens and the resist surface, referred to herein as the working distance, is less than 6mm or typically 1 mm. Due to a variety of factors such as short process cycle time, minimal working distance, and dynamics of the immersion stream, maintaining a consistent bubble free liquid between the lens and the resist-coated wafer is very difficult. Further, there is a lack of immersion fluids that have appropriate optical transmission characteristics and chemical compatibility with lithographic systems.
- 40 [0006] The desire to develop immersion systems is growing more acute because the ability to achieve resolution improvements via conventional means, such as wavelength reduction, appears to be increasingly difficult, particularly at wavelengths below 365 nm. In addition, with numerical apertures or NAs produced by lithographic methods using air as the immersion medium approaching the theoretical limit, progress using conventional methods is bounded. Accordingly, there is a need for an immersion fluid that is compatible with immersion lithographic systems, particularly those systems having an operative wavelength below 365 nm.

BRIEF SUMMARY

- 50 [0007] Immersion fluids comprising at least one carrier medium, immersion fluids comprising at least one carrier medium and at least one additive, and the additives used therein are disclosed herein. In one aspect of the present invention, there is provided an immersion fluid comprising: about 1 ppm to a maximum solubility limit of at least one additive selected from an alkyl alcohol; an alkyl ethoxylate, an alkyl propoxylate, and derivative thereof; an alkyl acid ester; an alkyl amine comprising an amine group; an alkyl amine ethoxylate; an acetylenic alcohol, an acetylenic diol, and ethylene oxide/propylene oxide derivatives thereof; an alkyl polyglycoside; a block oligomer; a polymer of ethylene and propylene oxide; a glycidyl ether; a glucamine derivative of a glycidyl ether; an urea; a siloxane-containing compound; a fluorinated or partially fluorinated acetylenic alcohol, diol and derivatives thereof; a fluorosurfactant; an ionic
- 55

liquid; a salt; and an electrolyte, provided that if the at least one additive is a fluorosurfactant then the immersion fluid comprises about 1 % by weight or greater of an aqueous fluid.

[0008] Preferably the at least one additive comprises the alkyl alcohol. Preferably the at least one additive comprises the alkyl acid ester. Preferably the at least one additive comprises the alkyl amine. Preferably the at least one additive comprises the alkyl amine ethoxylate. Preferably the at least one additive comprises the alkyl polyglycoside. Preferably the at least one additive comprises the block oligomer. Preferably the at least one additive comprises the polymer of ethylene oxide and propylene oxide. Preferably the at least one additive comprises the glycidyl ether. Preferably the at least one additive comprises the urea. Preferably the at least one additive comprises the fluorosurfactant. Preferably the at least one additive comprises the salt. Preferably the at least one additive is an electrolyte. Preferably the at least one additive comprises the fluorinated or the partially fluorinated acetylenic alcohol, diol, and derivatives thereof.

[0009] In another aspect of the invention, there is provided immersion fluid having a transmission of 50% or greater at an operating wavelength ranging from 140 nm to 365 nm comprising: at least one carrier medium selected from the group consisting of an aqueous fluid, a non-aqueous fluid, and mixtures thereof wherein the at least one carrier medium has a refractive index greater than or equal to water at the operating wavelength; and from about 1 ppm to the maximum solubility limit of at least one additive selected from an alkyl alcohol; an alkyl ethoxylate, an alkyl propoxylate, and derivative thereof; an alkyl acid ester; an alkyl amine comprising an amine group; an alkyl amine ethoxylate; an acetylenic alcohol, an acetylenic diol, and ethylene oxide/propylene oxide derivatives thereof; an alkyl polyglycoside; a block oligomer; a polymer of ethylene and propylene oxide; a glycidyl ether; a glucamine derivative of a glycidyl ether; an urea; a siloxane-containing compound; a fluorinated or partially fluorinated acetylenic alcohol, diol and derivatives thereof; a fluorosurfactant; an ionic liquid; a salt; and an electrolyte, provided that if the at least one additive is a fluorosurfactant then the immersion fluid comprises about 1 % by weight or greater of an aqueous fluid.

[0010] In a further aspect of the present invention, there is provided an immersion fluid having a transmission of 50% or greater at an operating wavelength ranging from 140 nm to 365 nm comprising: at least one carrier medium selected from an aqueous fluid, a non-aqueous fluid, and a mixture of the non-aqueous fluid and the aqueous fluid wherein the at least one carrier medium has a refractive index greater than or equal to water at the operating wavelength and wherein if the at least one carrier medium is the mixture then the non-aqueous fluid is water miscible.

BRIEF DESCRIPTION OF SEVERAL VIEWS OF THE DRAWINGS

[0011] Figure 1 provides the dynamic contact angle measurements for various embodiments of the immersion fluid of the present invention on unexposed 193 nm photoresists.

[0012] Figure 2 provides the absorbance spectra of ultra pure water and an embodiment of the immersion fluid of the present invention that was measured using a UV spectrometer.

[0013] Figure 3 provides comparison of the change in film thickness (nm) for various embodiments of the immersion fluid of the present invention compared to ultra pure water.

[0014] Figure 4 compares the absolute refractive index of various immersion fluids disclosed herein measured at a wavelength of 193 nm.

[0015] Figure 5 provides the dynamic contact angle measurements for various embodiments of the immersion fluid of the present invention on unexposed 193 nm photoresists.

DETAILED DESCRIPTION

[0016] Immersion fluids, comprising at least one carrier medium or comprising at least one carrier medium and at least one additive, useful for performing immersion lithography at operating wavelengths ranging from 140 to 365 nm, particularly 157 nm and/or 193 nm wavelengths are disclosed herein. The term "carrier medium" as used herein relates to an aqueous fluid, a non-aqueous fluid, or a mixture thereof that may be used by itself or have at least one additive added thereto to provide an immersion fluid. The term "fluid" as used herein describes a gas, liquid, a nanoparticle suspension, a supersaturated liquid, vapors, and combinations thereof. In embodiments wherein the aqueous fluid, non-aqueous fluid, and/or immersion fluid comprises a nanoparticle suspension, the average particle size of the nanoparticles contained therein is about 20% or less of the operating wavelength.

[0017] It is believed that the presence of the at least one additive within the at least one carrier medium such as, for example, a salt, a surfactant, an electrolyte or mixtures thereof within an immersion fluid, or the immersion fluid comprising at least one carrier medium without the addition of at least one additive, may provide at least one of the following benefits: improve the wetting of the immersion fluid onto the resist-coated substrate; reduce defect formation by substantially minimizing the formation of micro-bubbles and nano-bubbles; protect the resist surface by forming aggregations of one or more monolayers at the resist-immersion fluid interface or resist-protective-layer and immersion fluid interface thereby preventing leaching of any chemicals from the resist; minimize the feature size and maximize the resolution when added into an immersion fluid with a refractive index equal to or greater than water at the operating

wavelength, such as for example a refractive index equal to or greater than 1.44 at an operating wavelength of 193 nm, thereby allowing smaller feature sizes to be achieved; increase the refractive index of the immersion fluid if the carrier medium such as water has a low absorbance at wavelengths ranging from 140 to 365 nm provided that there is no interaction between the photoresist and the optics; and minimize the change in feature size upon exposure to light or heat by adding at least one additive to the carrier medium having the opposite refractive index/temperature characteristics (dn/dT) that may minimize or eliminate the change in refractive index upon exposure to laser light or heat. Further, the addition of at least one additive to a carrier medium, or the carrier medium itself, may provide an immersion fluid that does not significantly increase the absorbance of the immersion fluid at one or more operating wavelengths or maintains the absorbance below 5%, or below 1%, or below 0.5%. The immersion fluid containing at least one carrier medium and at least one additive, or the immersion fluid containing at least one carrier medium, may exhibit 50% or greater, 80% or greater, or 90% or greater total transmission.

[0018] As mentioned previously, the immersion fluid may comprise at least one carrier medium that is an aqueous fluid, a non-aqueous fluid, or a mixture thereof that may have at least one additive added thereto, or alternatively, the immersion fluid may be the carrier medium itself.

[0019] In certain embodiments, the carrier medium may comprise an aqueous fluid. In these embodiments, the refractive index may be equal to or greater than the refractive index of water at the operating wavelength such as, for example, a refractive index of 1.44 at an operating wavelength of 193 nm. Further, the aqueous fluid transmits light at the operating wavelengths of the lithography system such as a wavelength ranging from 140 to 365 nm. The term "aqueous" as used herein, describes a fluid dispersing medium, which comprises at least 80 weight percent, preferably 90 weight percent, and more preferably at least 95 weight percent water. Examples of suitable aqueous fluids include deionized water, ultra pure water, distilled water, doubly distilled water, and high performance liquid chemical (HPLC) grade water or deionized water having a low metal content.

[0020] In certain embodiments, the carrier medium may comprise a non-aqueous fluid. In these embodiments, the non-aqueous fluid is used in addition to, or in place of, an aqueous fluid. In these embodiments, the non-aqueous fluid selected preferably does not react with other components in the immersion fluid, the photoresist coating on the substrate, the system optics, or the substrate itself. In embodiments wherein the immersion fluid has at least one additive contained therein, the non-aqueous fluid preferably does not react with the at least one additive contained therein. Suitable fluids include, but are not limited to, hydrocarbons and derivatives thereof, including but not limited to, cyclic alkanes and acyclic alkanes (e.g. dodecane, hexane, pentane, hexadecane, cyclohexane, bicyclohexyl, tricyclohexane, decahydronaphthalene, and cyclopentane; fluorinated (partially or fully) hydrocarbons and derivatives thereof (e.g., perfluorocyclohexane and perfluorodecalin); SF_5 -functionalized hydrocarbons; halocarbons (e.g. Freon 113); ethers (e.g. ethylether (Et_2O), tetrahydrofuran ("THF"), ethylene glycol and derivatives thereof, monomethyl ether, or 2-methoxyethyl ether (diglyme)), and esters and derivatives thereof (e.g. sodium octanoate and sodium perfluorooctanoate). Still further exemplary fluids include lactates, pyruvates, and diols. These fluids include ketones such as, but are not limited to, acetone, ethyl acetate, cyclohexanone, acetone, N-methyl pyrrolidone (NMP), and methyl ethyl ketone. Other exemplary non-aqueous fluids include amides such as, but not limited to, dimethylformamide, dimethylacetamide, acetic acid anhydride, propionic acid anhydride, and the like. Exemplary non-aqueous fluids can include, but are not limited to, sulfur-containing compounds such as mercaptans (e.g., lauryl mercaptan), sulfones (e.g., dimethyl sulfone, diphenyl sulfone, sulfoxides (e.g., dimethyl sulfoxide). Still further non-aqueous fluids include alcohols such as, for example, propylene glycol propyl ether (PGPE), methanol, tetrahydrofurfuryl alcohol, 1-methylcyclohexanol, cyclohexanol, 2-methylcyclohexanol, adamantanemethanol, cyclopentanol, dimethyl-3-heptanol, dimethyl-4-heptanol, dodecanol, oleyl alcohol, pentanol, 1,5-pentanediol, 1,6-hexanediol, 1,4-butanediol, 1,2-propylene glycol, 1,3-propylene glycol, 1-dodecanol, cyclooctane, ethanol, 3-heptanol, 2-methyl-1-pentanol, 5-methyl-2-hexanol, cis-2-methylcyclohexanol, 3-hexanol, 2-heptanol, 2-hexanol, 2,3-dimethyl-3-pentanol, propylene glycol methyl ether acetate (PGMEA), ethylene glycol and derivatives thereof, polyethylene glycol and derivatives thereof, isopropyl alcohol (IPA), n-butyl ether, propylene glycol n-butyl ether (PGBE), 1-butoxy-2-propanol, 2-methyl-3-pentanol, 2-methoxyethyl acetate, 2-butoxyethanol, 2-ethoxyethyl acetoacetate, 1-pentanol, propylene glycol methyl ether, 3,6-dimethyl-3,6-octanol, maltose, sorbitol, mannitol, super, fully, and partially hydrolyzed poly(vinyl)alcohol, 1,3-butanediol, glycerol and derivatives thereof such as thioglycerol. Further non-aqueous fluids may comprise an acid such as, for example, sulfuric acid, lactic acid, octanoate acid, polyphosphoric acid, phosphoric acid, hexafluorophosphoric acid, tartaric acid, methane sulfonic acid, trifluoromethane sulfonic acid, dichloroacetic acid, propionic acid, and citric acid. Yet another non-aqueous fluid can be a silicone such as silicone oil. Still further non-aqueous fluids include 1,4-dioxane, 1,3-dioxolane, ethylene carbonate, propylene carbonate, ethylene carbonate, propylene carbonate, and m-cresol. The non-aqueous fluids enumerated above may be used alone, in combination with one or more other non-aqueous fluids, or in combination with an aqueous fluid.

[0021] In certain embodiments, the carrier medium may comprise a mixture of at least one aqueous fluid and at least one non-aqueous fluid. In these embodiments, the immersion fluid may contain at least one non-aqueous fluid that is miscible in the aqueous fluid or is water-miscible. The amount of non-aqueous fluid within the immersion fluid may

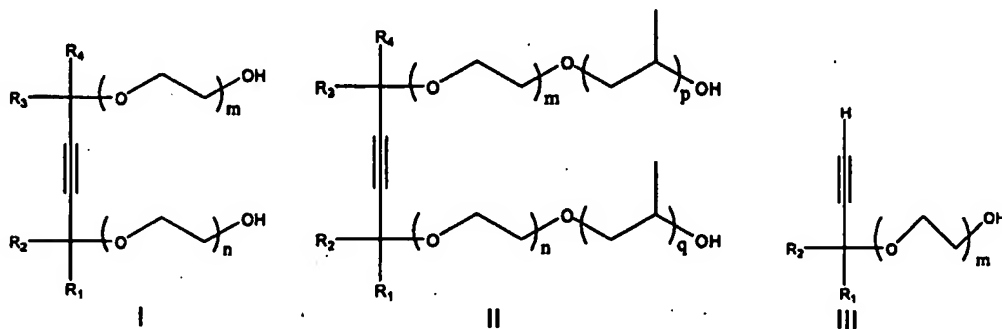
range from about 1 to about 99%, or from about 1 to about 50% by weight with the balance of the carrier medium within the immersion fluid comprising an aqueous fluid. Examples of water-miscible non-aqueous fluids include, but are not limited to, methanol, ethanol, isopropyl alcohol, glycerol, ethylene glycol and derivatives thereof, polyethylene glycol and derivatives thereof and THF.

[0022] In certain embodiments, certain non-aqueous fluids, having a refractive index greater than or equal to that of water and a specific absorbance of less than 1 cm^{-1} or less than 0.5 cm^{-1} at one or more operating wavelengths ranging from 140 to 365 nm may be added to the immersion fluid in the amount ranging from 0.1 to 100%, or from 1 to 50% to increase the refractive index of the immersion fluid. At an operating wavelength of 193 nm, the non-aqueous fluid may have a refractive index equal to or greater than that of water or greater than 1.44. Exemplary non-aqueous fluids that may be used at this operating wavelength include, but are not limited to, citric acid ($n = 1.496$), bicyclohexyl ($n = 1.477$), glycerol ($n = 1.4730$), or cis-2-methylcyclohexanol ($n = 1.4633$).

[0023] In certain embodiments, the immersion fluid comprises from 10 parts per million (ppm) to the maximum solubility limit, or from 1 ppm to 50% by weight, or from 10 ppm to 10,000 ppm of at least one additive. The term "maximum solubility limit" as used herein relates to the maximum amount of the at least one additive that can be added to the carrier medium to provide a homogenous solution without phase separation and/or precipitation of the at least one additive. Examples of at least one additive that may be used alone, or in combination with one or more other at least one additives, within an immersion fluid include: an alkyl alcohol such as, for example, a polymeric alcohol having one or more hydroxyl groups; an alkyl ethoxylate, an alkyl propoxylate, and (PO) derivatives thereof which may further include mono- and multi- hydrophilic units (such as diols); an alkyl acid ester such as, for example, an alkyl carboxylate or an alkyl acid ester with mono- and multi-carboxyl units; an alkyl amine such as one having one or more amine groups including primary, secondary and tertiary amines; an alkyl amine ethoxylate; an acetylenic alcohol, an acetylenic diol, and ethylene oxide/propylene oxide derivatives thereof; an alkyl polyglycoside; a block oligomer; a polymer of ethylene and propylene oxide; a glycidyl ether or a glucamine derivative of the glycidyl ether with an at least one selected from an alkyl amine, an alkyl diamine, an alkyl alcohol, an acetylenic alcohol, and combinations thereof; an urea such as an alkyl urea or a dialkyl urea; a siloxane-containing compound such as, for example, a polysiloxane, a poly(dimethyl) siloxane, a polysiloxane polyester copolymer, or derivatives thereof; a fluorinated or partially fluorinated acetylenic alcohol, diol or derivatives thereof; a fluorosurfactant; a salt; and an electrolyte. The additives enumerated above may be used alone or in combination with one or more other additives.

[0024] In certain embodiments, at least one additive is a surfactant. Typical surfactants exhibit an amphiphilic nature, meaning that they can be both hydrophilic and hydrophobic at the same time. Amphiphilic surfactants possess a hydrophilic head group or groups, which have a strong affinity for water and a long hydrophobic tail, which is organophilic and repels water. In embodiments wherein the at least one additive is a surfactant, the surfactant may be ionic (i.e., anionic, cationic, amphoteric) or nonionic.

[0025] In certain embodiments of the present invention, the immersion fluid may contain at least one additive that is an acetylenic alcohol, an acetylenic diol, or an ethylene oxide/propylene oxide derivative thereof. Exemplary acetylenic alcohol, acetylenic diol or ethylene oxide/propylene oxide derivatives that can be used as the at least one additive within an immersion fluid may be represented by the following formulas I through III:

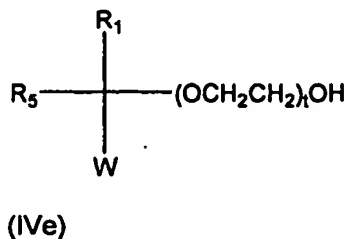
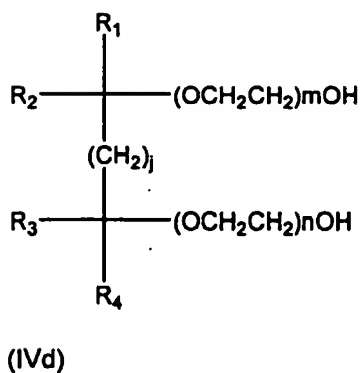
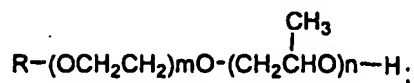
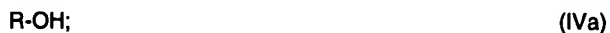


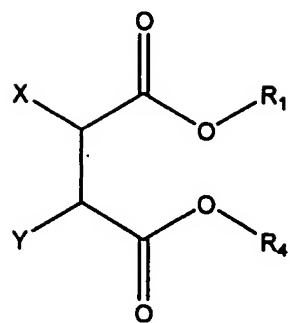
wherein R₁ and R₄ are each independently a straight or a branched alkyl chain having from 3 to 10 carbon atoms; R₂ and R₃ are each independently a hydrogen atom or an alkyl chain having from 1 to 5 carbon atoms; and m, n, p, and q are each independently a number that ranges from 0 to 20. The at least one additive having the formula I, II or III are commercially available from Air Products and Chemicals, Inc. of Allentown, PA, the assignee of the present invention, under the trade names SURFYNOL® and DYNOL®. In certain embodiments, the acetylenic diol portion of the

molecule of formulas I or II is 2,4,5,9-tetramethyl-5-decyne-4,7-diol or 2,5,8,11-tetramethyl-6-dodecyne-5,8-diol. The at least one additives having the formulas I through III may be prepared in a number of ways including the methods described, for example, in U. S. Pat. No. 6,313,182 and EP 1115035A1, which are assigned to the assignee of the present invention and incorporated herein by reference in their entirety.

[0026] In formulas I and II, the alkylene oxide moieties represented by $(OC_2H_4)_n$ are the $(n + m)$ polymerized ethylene oxide (EO) molar units and the moieties represented by $(OC_3H_6)_p$ are the $(p + q)$ polymerized propylene oxide (PO) molar units. The value of $(n + m)$ may range from 0 to 30, preferably from 1.3 to 15, and more preferably from 1.3 to 10. The value of $(p + q)$ may range from 0 to 30, preferably from 1 to 10, and more preferably from 1 to 2.

[0027] In other embodiments, the immersion fluid may contain from 1 ppm to the maximum solubility limit or from 1 ppm to 50% by weight or from 10 ppm to 10,000 ppm of at least one additive that is represented by the following formulas (IV) through (XI):





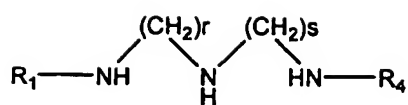
(Va)



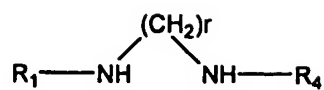
(Vb)



(Vc)



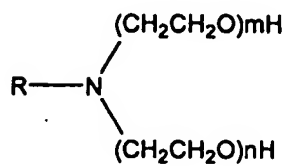
(Vla)



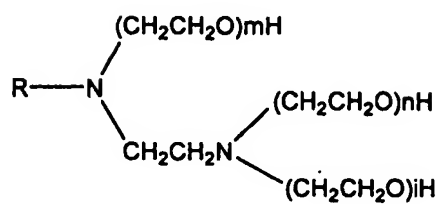
(Vlb)



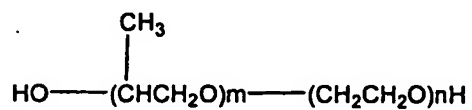
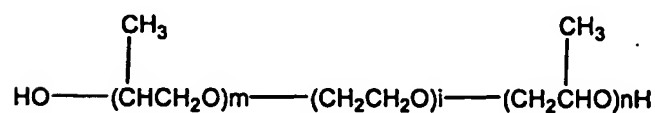
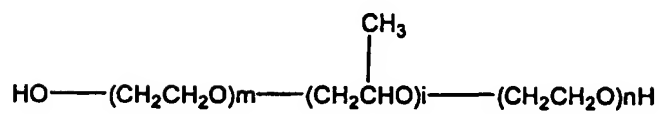
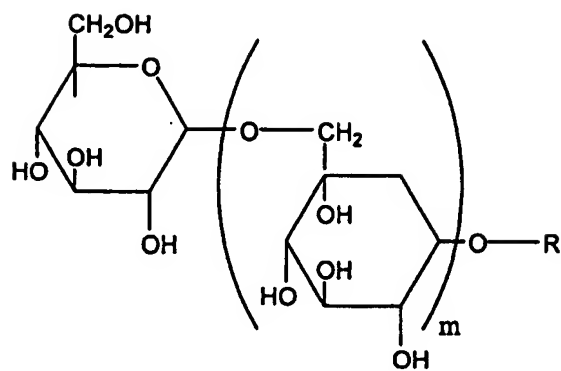
(Vlc)

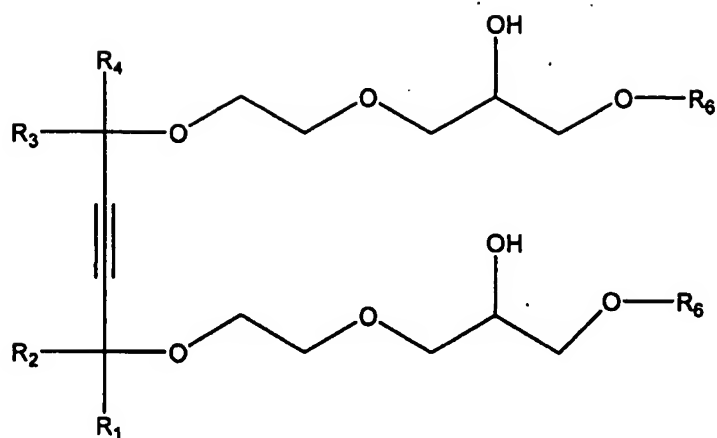


(Vld)

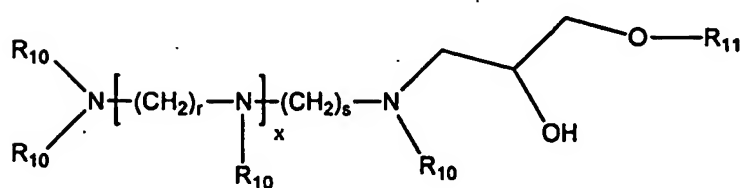


(Vle)

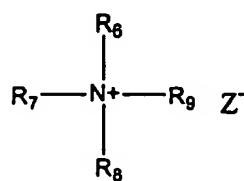




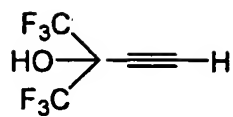
(IXa)



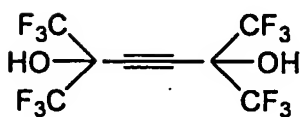
(IXb)



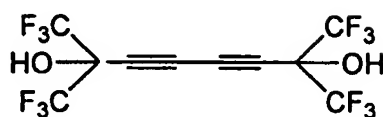
(X)



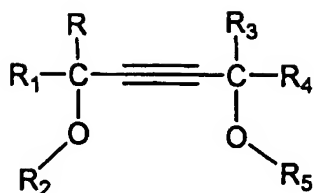
(XIa)



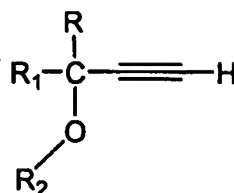
(XIb)



(XIc)

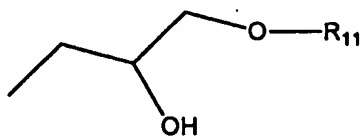


(XId)



(XIe)

[0028] In each of the above formulas, R, R₁ and R₄ are each independently a straight, branched, or cyclic alkyl, fluoroalkyl, or perfluoroalkyl group having from 2 to 25, or from 3 to 10 carbon atoms; R₂ and R₃ are each independently a hydrogen atom, a straight, a branched or a cyclic alkyl group, fluoroalkyl group, or perfluoroalkyl group having from 1 to 10 or from 1 to 5 carbon atoms; R₅ is a straight, a branched, or a cyclic alkyl, fluoroalkyl, or perfluoroalkyl group having from 1 to 10 carbon atoms; R₆ is a straight, a branched, or a cyclic alkyl, fluoroalkyl, or perfluoroalkyl group having from 4 to 16 carbon atoms; R₇, R₈ and R₉ are each independently a straight, a branched, or a cyclic alkyl, fluoroalkyl or perfluoroalkyl group having from 1 to 6 carbon atoms; R₁₀ is independently H or a group represented by the formula



R¹¹ is a straight, a branched, or a cyclic alkyl group having from 4 to 22 carbon atoms; W is a hydrogen atom or an alkynyl group; X and Y are either a hydrogen atom or a hydroxyl group; Z⁻ is either a halide atom, a hydroxyl group, an acetate group, or a carboxylate group; m, n, p, q are each independently a number ranging from 0 to 20; r and s are each independently 2 or 3; t is a number ranging from 0 to 2; i is a number ranging from 0 to 20; x is a number ranging from 1 to 6, and M is a monovalent metal ion or an ammonium ion.

[0029] The at least one additive may be an alkyl alcohol such as, for example, a polymeric alcohol having one or more hydroxyl groups. Exemplary alkyl alcohols or polymeric alcohols include sugar alcohols such as sorbitol or polyvinyl alcohols. The at least one additive may be an alkyl alcohol, an alkyl ethoxylate, or a propylene oxide derivative thereof. Exemplary alkyl alcohols, alkyl ethoxylates, or propylene oxide derivatives that can be used as at least one additive within an immersion fluid may be represented by formulas IVa through IVe. A specific example of a Formula IVd additive is 2,4,7,9-tetramethyl-4,7-decane diol. Examples of Formula IVe additives include, but are not limited to, 3,5-dimethyl-1-hexyn-3-ol and 2,6-dimethyl-4-heptanol. The at least one additive may be an alkyl acid ester such as an alkyl carboxylate. Exemplary alkyl carboxylates or alkyl acid esters that can be used as at least one additive within an immersion fluid may be represented by formulas Va through Vc. An example of a Formula Va additive includes, but is not limited to, diisopentyl tartrate. The at least one additive may be an alkyl amine having one or more amine groups including primary, secondary and tertiary amines or an alkyl amine ethoxylate. Exemplary alkyl amines or alkyl amine ethoxylates that can be used as at least one additive within an immersion fluid may be represented by formulas Via through Vle. An example of a Formula Via additive includes, but is not limited to, N,N'-bis(1,3-dimethylbutyl) ethylene diamine. The at least one additive may be an alkyl polyglycoside. An exemplary alkyl polyglycoside that can be used as at least one additive within an immersion fluid is represented by formula VII. The at least one additive may be a block oligomer or a polymer of ethylene and propylene oxide. Exemplary block oligomers or polymers of ethylene and propylene oxide that can be used as at least one additive within an immersion fluid may be represented by formulas VIIa through VIIc. The at least one additive may be a glycidyl ether or a glucamine derivative with an alkyl amine, an alkyl diamine, an alkyl alcohol, or an acetylenic alcohol. Exemplary glycidyl ether or glucamine derivatives that can be used as at least one additive within an immersion fluid may be represented by formulas IXa through IXb. An example of a Formula IXb additive includes, but is not limited to, an adduct of diethylenetriamine and n-butyl glycidyl ether. The at least one additive may be an urea, such as, for example, an alkyl urea or a dialkyl urea. The at least one additive may be a fluorinated or partially fluorinated acetylenic alcohol or diol and derivatives thereof. Exemplary fluorinated or

partially fluorinated acetylenic alcohol or diol and derivatives thereof that can be used as at least one additive within an immersion fluid may be represented by formulas Xla through Xle. An example of a Formula Xla additive includes, but is not limited to, hexafluoropropanol acetylene.

[0030] The at least one additive may be a fluorosurfactant provided that the carrier medium comprises at least 1 % by weight or greater of an aqueous fluid. Exemplary fluoro-surfactants include: straight, branched, or cyclic hydrofluorocarbons having 2 to 10 carbon atoms wherein there are more fluorine atoms than hydrogen atoms; $F(CF_2(CF_2)CF_2)_n-O-[CH_2CH_2O]_m-H$; $F(CF_2(CF_3)CF_2O)_nCFHCF_3$ wherein n is a number ranging from 1 to 5; $F(CF_2(CF_3)CF_2O)_nCF_2CF_3$ wherein n is a number ranging from 1 to 5; and

$HCF_2(OCF_2)_n(OCF_2CF_2)_m-O-CF_2H$ wherein (n+m) is a number ranging from 1 to 8; a mixture of the ammonium salts of perfluorocarboxylic acids; fluoroaliphatic esters, $[F(CF_2CF_2)_{1-7}CH_2CH_2O]_xP(O)(ONH_4)_y$ where x=1 or 2; y=2 or 1; and x+y=3 in various weight solution of isopropanol in water ranging from 25-70 %; $[F(CF_2CF_2)_{1-7}CH_2CH_2O]_xP(O)(OH)_y$ where x=1 or 2; y=2 or 1; and x+y=3; $F(CF_2CF_2)_3-BCH_2CH_2SO_3H$ in a 4.5% by weight solution of acetic acid in water; ammonium salt of perfluoro-octanoic acid.

[0031] In certain embodiments, the at least one additive may be a salt. Exemplary salts include: metal salts, ammonium salts, sulfonium salts, phosphonium salts, halide salts, sulfate salts, sulfide salts, sulfonate salts, sulfite salts, phosphate salts, phosphonate salts, phosphite salts, and derivatives thereof. Examples of metal salts include alkali earth metal salts, such as barium chloride, calcium fluorophosphates dehydrate, calcium fluoride (n = 1.4338), magnesium chloride, and magnesium sulfate; alkali metal salts such as lithium chloride, potassium chloride, sodium chloride (n = 1.5443), sodium bisulfite, cesium bisulfate, cesium hydrogen phosphate, cesium methane sulfonate, cesium perchlorate, and cesium phosphate; and transition metal salts such as cadmium chloride. In certain embodiments, the salt may be a phosphonium salt such as, for example, tetrabutylphosphonium chloride, tetrabutylphosphonium methane sulfonate, tetrabutylphosphonium phosphate, tetrabutylphosphonium bromide, tetraoctylphosphonium bromide, trihexyl(tetradecyl)-phosphonium hexafluorophosphate, trihexyl(tetradecyl)-phosphonium hexafluorophosphate, and trihexyl(tetradecyl)-phosphonium bis(trifluoromethylsulfonyl)imide. In certain embodiments, the salt may be a sulfonium salt such as, for example, a trialkyl sulfonium salt such as trimethylsulfonium salt. In certain embodiments, the salt may be a sulfate salt or an alkyl or alkyl ethoxylate derivative thereof such as, for example, dimethyl sulfate, dodecyl sulfate sodium salt, methyl (tributyl)-phosphonium methyl sulfate, sodium dodecyl sulfate, sodium octyl sulfate, zinc sulfate, cadmium sulfate, cesium sulfate, and lanthanum sulfate. In certain embodiments, the salt may be a sulfonate salt such as, for example, an alkyl sulfonate, an alkyl ethoxylate sulfonate, adamantemetane sulfonate, potassium adamantane sulfonate, and sodium xylene sulfonate. In certain embodiments, the salt may be a halide salt such as, for example, aluminum chloride, aluminum bromide, aluminum fluoride, and aluminum iodide. The at least one additive may be an ammonium salt such as alkyl ammonium salt.

[0032] In certain embodiments, the at least one additive may be an electrolyte. In certain particular embodiments, the electrolyte may exhibit a refractive index equal to or greater than that of water and a specific absorbance less than 1 cm^{-1} , or less than 0.5 cm^{-1} , at an operating wavelength ranging from 140 to 365 nm. In embodiments wherein the operating wavelength is 193 nm, the refractive index is equal to or greater than 1.44.

[0033] In certain embodiments, the immersion fluid may contain an ionic liquid. The term "ionic liquid" as used herein describes an organic salt that is liquid at, or close to room temperature. In these embodiments, the ionic liquid may be added to the immersion fluid as an additive to, for example, an aqueous fluid and/or a non-aqueous fluid. Examples of suitable ionic liquids that can be used herein include lanthanum III trifluoromethane sulfonate, tetramethyl ammonium hexafluorophosphonate, tetrabutylphosphonium, tris(pentafluoroethyl)trifluorophosphate, tetraethylammonium bis(malonato(2-))borate, and 1-ethyl-1-methylpyrrolidinium hexafluorophosphate.

[0034] Various other components may be optionally added to the immersion fluid. These components may include, but are not limited to, stabilizers, dissolving aids, colorants, wetting agents, antifoamers, buffering agents, and other additional surfactants. Generally, the amount of each of these additives would be about 0.0001 to 1 percent by weight, or about 0.0001 to 0.1 percent by weight, based upon the total weight of the immersion fluid. In embodiments where one or more additional surfactants are added to the immersion fluid, the surfactant may be any of the surfactants disclosed herein or provided in the reference McCutcheon's Emulsifiers and Detergents.

[0035] In embodiments where the immersion fluid contains at least one additive, the immersion fluid may be prepared by mixing the at least one additive with at least one carrier medium which can be an aqueous and/or non-aqueous fluid and any additional components. In certain embodiments, one or more aqueous fluids such as ultra pure or HPLC water is combined with from about 1 ppm to the maximum solubility limit, or from about 1 ppm to about 50% by weight or from about 10 ppm to about 10,000 ppm, of at least one additive to provide the immersion fluid. In an alternative embodiment, from about 1 ppm to the maximum solubility limit, or from about 1 ppm to about 50% by weight, or from about 10 ppm to about 10,000 ppm, of at least one additive is combined with one or more aqueous fluids until a homogeneous mixture is formed and is then combined with one or more non-aqueous fluids to provide the immersion fluid. In a still further embodiment, one or more non-aqueous fluids such as the fluids disclosed herein are combined with from about 1 ppm to the maximum solubility limit of at least one additive to provide the immersion fluid. In the

foregoing embodiments, the combining may be done at a temperature range of from about 20 to 60°C or from about 40 to 60°C to affect dissolution of the ingredients contained therein and provide a homogeneous mixture. The resulting immersion fluid may optionally be filtered to remove any undissolved particles that could potentially harm the substrate.

[0036] In alternative embodiments, the immersion fluid may comprise the carrier medium, i.e., at least one aqueous fluid, at least one non-aqueous fluid, and mixtures thereof. In embodiments wherein the immersion fluid is a mixture of carrier media, the combining may be done at a temperature range of about 20 to 60°C or from 40 to 60°C to provide a homogeneous mixture.

[0037] The immersion fluid is preferably used to treat at least a portion of the surface of a substrate that is coated with a photoresist or resist coating. Suitable substrates include, but are not limited to, materials such as gallium arsenide ("GaAs"), silicon, tantalum, copper, ceramics, aluminum/copper alloys, polyimides, and compositions containing silicon such as crystalline silicon, polysilicon, amorphous silicon, epitaxial silicon, silicon dioxide ("SiO₂"), silicon nitride, doped silicon dioxide, and the like. Further exemplary substrates include silicon, aluminum, or polymeric resins. In certain embodiments, the immersion fluid contacts at least a portion of a substrate coated with a photoresist, or a resist-coated substrate and is substantially non-reactive to the resist coating. Exemplary resist coatings include, but are not limited to, novolac resin, polyvinyl phenol copolymer, or copolymers of p-hydroxystyrene and t-butyl acrylate.

[0038] The immersion fluid is applied to at least a portion of a substrate having a photoresist coating applied thereto. The photoresist-coated substrate is then exposed to radiation through an optical device to provide a pattern that is imposed upon the photoresist coating. Examples of radiation sources that may be used include ultraviolet (uv) light, electron beam, x-ray, laser, lamp, or ion beams. In certain embodiments, the radiation source emits light at wavelengths at an operating wavelength ranging from 140 nm to 365 nm such as 193 nm and 157 nm. In some embodiments, a pre-bake or soft-bake step may be conducted prior to the exposure step. This pre-bake or soft bake step may be conducted, for example, at a temperature ranging from 90°C to 150°C for a time or from 30 to 120 seconds on a hot plate.

[0039] Depending upon whether the photoresist coating is positive or negative, the radiation either increases or decreased its solubility in a subsequently applied alkaline developer solution such as a process solution containing tetramethylammonium hydroxide (TMAH), potassium hydroxide, sodium hydroxide, or other base. Further examples of developer solutions include those provided in U. S. Patents 6,455,234; 6,268,115; 6,238,849; 6,127,101; and 6,120,978. In a positive photoresist coating, the areas masked from radiation remain after development while the exposed areas are dissolved away. In a negative photoresist coating, the opposite occurs. The immersion fluid of the present invention may be suitable to treat substrates having either positive or negative photoresist coatings. The patterned photoresist image may be developed by a variety of different means, including but not limited to quiescence, immersion, spray, or puddle development. After the patterned photoresist image is developed, the substrate is baked to harden the polymer contained within the photoresist. The bake step may be conducted, for example, at a temperature ranging from 70°C to 150°C for a time duration of from 30 to 120 seconds.

[0040] A typical immersion lithography process uses an apparatus that has a servomotor driven wafer stage that supports and positions a resist-coated substrate or wafer underneath an optic device such as a lens. The optic device may also be a prism, a mirror or combinations thereof. The immersion fluid is dispensed onto at least a portion of resist-coated substrate through one or more nozzles to form a puddle. A radiation source that emits light at the operating wavelength then passes through lens and the puddle of immersion fluid prior to exposure to at least a portion of the resist-coated substrate.

[0041] The immersion fluid is preferably applied to the photoresist-coated substrate as a prepared solution. In alternative embodiments, however, the immersion fluid can be prepared within the application stream just prior to or during contact with the substrate surface. For example, a certain quantity of one or more additives can be injected into a continuous stream of aqueous fluid and/or non-aqueous fluid medium or immersion fluid that optionally includes additives thereby forming the immersion fluid. In some embodiments of the present invention, a portion of the at least one additive may be added to the substrate after application of the immersion fluid. In still other embodiments of the present invention, the at least one additive can be also deposited upon or comprise the material of a high surface area device such as a cartridge or filter (which may or may not include other components). A stream of aqueous fluid and/or non-aqueous fluid then passes through the cartridge or filter thereby forming the immersion fluid. In still another embodiment of the present invention, the immersion fluid is prepared during the contacting step. In this connection, at least one additive is introduced via a dropper or other means to the surface of the substrate. Aqueous fluid and/or non-aqueous fluid medium is then introduced to the surface of the substrate and mixes with the at least one additive on the surface of the substrate thereby forming the immersion fluid.

[0042] In an alternative embodiment of the invention, a concentrated composition comprising at least one additive is provided that may be diluted in an aqueous fluid and/or non-aqueous fluid medium to provide the immersion fluid. A concentrated composition of the invention, or "concentrate" allows one to dilute the concentrate to the desired strength and pH. A concentrate also permits longer shelf life and easier shipping and storage of the product.

[0043] A variety of means can be employed in contacting the immersion fluid with the substrate surface. The actual conditions of the contacting step (i.e., temperature, time, and the like) may vary over wide ranges and are generally

dependent on a variety of factors such as, but not limited to, the nature and amount of residue on the surface of the substrate and the hydrophobicity or hydrophilicity of the substrate surface, etc. The contact step can be conducted in either a dynamic method such as, for example, a streamline process for applying the immersion fluid over the surface of the substrate or in a static method such as, for example, a puddle application. The immersion fluid may also be sprayed onto the surface of the substrate in a dynamic method such as in a continuous process or sprayed onto the surface and allowed to remain there in a static method. The duration of the contacting step, or time of contact of the immersion fluid to the substrate surface, can vary from a fraction of a second to hundreds of seconds. Preferably, the duration can range from 1 to 200 seconds, or from 1 to 150 seconds, or from 1 to 40 seconds. The temperature range for the contacting step can vary from 10 to 100°C, or from 10 to 40°C.

EXAMPLES

Example 1. Dynamic surface tension

[0044] The dynamic surface tension (DST) data was collected via the maximum bubble pressure method described in Langmuir 1986, 2, pp. 428-432. The data was collected at bubble rates that range from 0.1 bubbles/second (b/s) to 20 b/s using the Kruss BP2 bubble pressure tensiometer manufactured by Kruss, Inc. of Charlotte, N.C.

[0045] The dynamic surface tension data provides information about the performance of the at least one additive at conditions from near-equilibrium (0.1 b/s) to relatively high surface creation rates (20 b/s). High bubble rates may correspond to a dynamic liquid injection process in an immersion lithography process. It is desirable that the dynamic surface tension be reduced below that of ultrapure water at high bubble rates (i.e., 70-72 dyne/cm at 20 b/s) to provide, *inter alia*, better wetting of the photoresist-coated substrate. Table I provides the DST of immersion fluids containing varying concentrations of the alkyl diol additive 2,4,7,9-tetramethyl-4,7-decane diol added to a 100 mL quantity of the aqueous fluid ultra pure water. The alkyl diol additive is added to the ultra pure water at ambient temperature while stirring to provide a homogeneous solution. The immersion fluids exhibited dynamic surface tensions at high bubble rates below that of water or 72 dyne/cm. This indicates that the immersion fluid of the present invention may be effective at reducing the surface tension of water in a dynamic process.

Table I:

Dynamic Surface Tension					
Additives Conc.	DST (dyne/cm) 0.1 b/s	DST (dyne/cm) 1 b/s	DST (dyne/cm) 6 b/s	DST (dyne/cm) 1 5 b/s	DST (dyne/cm) 20 b/s
0.01wt%	48.7	54.0	61.9	67.8	69.0
0.03wt%	41.8	43.7	47.5	53.6	56.5
0.05wt%	38.5	39.6	41.8	45.6	47.6

Example 2 Wetting Property:

[0046] The wetting properties of immersion fluids containing an alkyl diol additive, 2,4,7,9-tetramethyl-4,7-decane diol, and ultra pure water as a comparison, was measured on the G10/DSA10 Kruss drop shape analyzer provided by Kruss USA of Charlotte, N.C. using the Sessile drop method. In this method, the wetting properties of a localized region on the surface of a photoresist-coated substrate are estimated by measuring the contact angle between the baseline of a droplet of aqueous developer solution and the tangent at the droplet base. A high-speed camera captured the spreading of the droplet at a speed of 2 frames per second for 2 minutes and the contact angle was measured. The photoresist is a typical acrylate type 193nm resist.

[0047] In general, lower contact angles indicate better wetting properties on resist surface. As Table II illustrates, the addition of additive improved the wetting on the resist surface.

Table II:

Comparison of Contact Angles of UPW vs. Immersion Fluid				
Fluid	Contact Angle (0 sec)	Contact Angle (5 sec)	Contact Angle (10 sec)	Contact Angle (30 sec)
Ultra pure water	62.9	62.9	62.5	61.6
0.02wt% additive	54.1	53.5	52.8	51.8

Example 2a through 2e and Comparative Example (HPLC water):

[0048] A quantity of 0.01% by weight or 100 ppm of the following additives: hydrophobically modified acetylenic diol or oxirane [(2-Ethyl Hexyl) Oxy]Methyl]-, Rx prod w/polyethylene glycol ether with 2,4,7,9-tetramethyl-5-decyne-4,7-diol (2:1); 2,4,7,9-tetramethyl-4,7-decane diol; ethoxylated 2,4,7,9-tetramethyl-4,7-decane diol; polysiloxane-polyester copolymer or TEGOWETTM manufactured by Goldschmidt Chemical of McDonald, PA; and an ethoxylated nonionic fluorosurfactant or ZONYLTM FSO with the formula: $F(CF_2CF_2)_1-7CH_2CH_2O(CH_2CH_2O)_yH$ where $y=0$ to ca. 15 manufactured by Dupont of Wilmington, DE were each combined with 100 mL of the aqueous fluid HPLC water manufactured by Aldrich Chemical to provide immersion fluids 2a through 2e, respectively. The additives were added to the aqueous fluid, HPLC water, at ambient temperature while stirring to provide a homogeneous mixture. Dynamic contact angle measurements, or the contact angle measurement over a period of time, measured on unexposed 193 nm photoresist-coated substrates for each of the immersion fluids 2a through 2e and HPLC water as a comparative were obtained in accordance with the method disclosed in Example 2. The results of the dynamic contact angle measurements are provided in Figure 1.

Example 3:

[0049] The absorbance of immersion fluids was measured with a UV spectrometer. The wavelength was scanned from 210nm to 185nm. As shown in Figure 2, at 193nm wavelength, the addition of 0.02wt% of the additive 2,4,7,9-tetramethyl-4,7-decane diol only increased the absorbance slightly. The additive is enough to lower the contact angle on resist by 15% while only adding 0.03-0.05 cm^{-1} to the absorbance. This absorbance is low enough to allow 1 mm working distance between optics and resist surface which maintaining the total transmission > 95%. The improved wetting may lead to more uniform image formation across the wafer and enhance the image resolution.

Example 4:

[0050] A quartz crystal microbalance (QCM) was used to study changes in film thickness of unexposed 193nm photoresist solutions. A CH Instruments model CHI 405 was used as a driver and high-resolution frequency counter. The instrument was fitted with a flow cell. The quartz crystals were made by International Crystal Manufacturing. The electrode was gold, 1000A thick and 0.201" in diameter. The crystal resonance frequency was 7.995 MHz \pm 10 Hz. The quartz crystals were spin-coated with a photoresist solution. The spin recipe was 1200 revolutions per minute (RPM) for 30 seconds and 3000 RPM for 10 seconds. The post apply bake (PAB) was 4 min at 125 °C. The crystals were then exposed to UV light for the desired time. Each crystal was then mounted on a sensor probe and placed in the liquid flow cell. The instrument was controlled by a Dell PC using CHI software program. Frequency data was collected every 0.01 second. The flow of immersion fluid containing 0.01 weight percent of at least one additive was started 15 seconds after data acquisition started, to ensure that there were no glitches in the data acquisition process. The residence time through the flow cell was approximately 2 seconds. The experiment was stopped after 2 minutes. Figure 3 provides a comparison of the change in film thickness in nm for immersion fluids containing 0.01 % by weight or 100 ppm of the additives dimethyl-4-heptanol, hydrophobically modified acetylenic diol, and ethoxylated nonionic fluorosurfactant in 100 ml of ultrapure water and ultrapure water as a comparative.

Example 5:

[0051] Various immersion fluids containing 0.01 % by weight of at least one additive in 200 ml of the aqueous fluid ultrapure water were prepared at ambient temperature by mixing to form a homogeneous solution. Each immersion fluid was tested for foam dissipation using the Ross-Miles foam height test or ASTM D1173-53. The results of this test for each immersion fluid is provided in Table III.

Table III

Additive	Initial Foam Height (cm)	Time to 0 foam (seconds)	Dynamic Foam Height (1)
2,4,7,9-tetramethyl-decane-4,7-diol	0	0	0
2-Hydroxy-succinic acid dibutyl ester	1.5	0	0

(1) Remaining foam after 1 minute measured in cm.

Table III (continued)

Additive	Initial Foam Height (cm)	Time to 0 foam (seconds)	Dynamic Foam Height (1)
Ethoxylated 2,4,7,9-tetramethyl- 5-decyn-4,7-diol	1.3	30	0
Hydrophobically modified acetylenic diol	1.7	>300	1.0
Polysiloxane-polyester copolymer	0.4	3	0

(1) Remaining foam after 1 minute measured in cm.

Example 6a through 6j:

[0052] Various immersion fluids were prepared at ambient temperature by mixing to form a homogeneous solution. The identity of the carrier medium that comprises the immersion fluid, and the additive within the immersion fluid if present, are provided in Table IV. The optical properties, i.e., the absorption, absolute refractive index, and the change in refractive index with temperature (dn/dT), of the exemplary immersion fluids and a comparative example HPLC water were measured and the results are provided in Table IV. Figure 4 compares the absolute refractive index of various immersion fluids disclosed herein measures at a wavelength of 193 nm. The absorption, or A/I , was measured using a double beam UV-Visible Light, Lambda 900 Spectrometer manufactured by Perkin-Elmer at a wavelength of 193 nm. The absolute refractive index was measured using an experimental unit referred to VUV Hilger-Chance Refractometer/ Goniometer at a wavelength of 193 nm and temperature of 21.5°C. The change in refractive index with temperature (dn/dT) was measured by placing the fluid samples in a V-Groove fused silica cell into a goniometer, which is temperature-controlled and sealed from the atmosphere under stringent temperature control (± 0.01 °C). The goniometer obtained measurements of absolute refractive index with absorption path-lengths $\geq 500\mu\text{m}$ at a wavelength of 193nm or 157nm.

[0053] The results in Table IV illustrate that the immersion fluids described herein can provide a higher refractive index and a dn/dT of zero relative to that of Comp. Ex. or water. In certain instances, immersion fluids having a relatively higher refractive index may enable Numerical Apertures ($NA > 1$) needed for sub-45nm nodes. Use of these fluids may also greater depth of focus to be achieved and may bridge the gap between water-based 193nm Immersion and Extreme-UV lithography.

[0054] Dynamic contact angle measurements, or the contact angle measurement over a period of time, measured on unexposed 193 nm photoresist-coated substrates for immersion fluids 6b, 6g, 6j, 6k, and 6k and HPLC water as a comparative were obtained in accordance with the method disclosed in Example 2. The results of the dynamic contact angle measurements are provided in Figure 5.

Table IV

Example	Additive	Carrier Medium	Absorption (cm ⁻¹) @ 193 nm	n @ 193 nm (21.5 °C)	dn/dT (°C)
Comp. Ex.	--	Water (HPLC)	0.0400	1.4366	-1.00E-04
Ex. 6a	Zinc Sulfate (50%)	Water (HPLC) (50%)	3.3050	1.4884	-1.60E-04
Ex. 6b	Cesium methane sulfonate (70%)	Water (HPLC) (30%)	1.9390	1.5154	-
Ex. 6c	Trimethylsulfonium methyl sulfate (40%)	Water (HPLC) (60%)	2.6230	1.4885	-
Ex. 6d	--	1,3-Butanediol	5.4860	1.4656	-1.60E-04
Ex. 6e	Polyvinyl alcohol (10%)	Water (HPLC) (90%)	5.3970	1.4556	7.90E-05
Ex. 6f	--	Glycerol	>6	1.6159	-2.88E-04

Table IV (continued)

Example	Additive	Carrier Medium	Absorption (cm ⁻¹) @ 193 nm	n @ 193 nm (21.5 °C)	dn/dT (°C)
Ex. 6g	--	Dodecane	1.1440	1.5573	-
Ex. 6h	--	Bicyclohexyl	>6	1.6438	-7.30E-04
Ex. 6i	--	Cyclohexane	1.5230	1.5655	-
Ex. 6j	--	Methane sulfonic acid (50%)/Water (HPLC) (50%)	0.9400	1.5010	-2.50E-04
Ex. 6k	--	Decalin	>6	1.5606	-
Ex. 6l	--	Glycerol (50%)/ Water (HPLC) (50%)	>6	1.5727	-

Claims

1. An immersion fluid comprising: about 1 ppm to a maximum solubility limit of at least one additive selected from an alkyl alcohol; an alkyl ethoxylate, an alkyl propoxylate, and derivatives thereof; an alkyl acid ester; an alkyl amine comprising an amine group; an alkyl amine ethoxylate; an acetylenic alcohol, an acetylenic diol, and ethylene oxide/propylene oxide derivatives thereof; an alkyl polyglycoside; a block oligomer; a polymer of ethylene and propylene oxide; a glycidyl ether; a glucamine derivative of a glycidyl ether; urea; a siloxane-containing compound; a fluorinated or partially fluorinated acetylenic alcohol, diol and derivatives thereof; a fluorosurfactant; an ionic liquid; a salt; and an electrolyte, provided that if the at least one additive is a fluorosurfactant then the immersion fluid comprises about 1 % by weight or greater of an aqueous fluid.
2. The immersion fluid of claim 1 wherein the at least one additive comprises at least one selected from the acetylenic alcohol, the acetylenic diol, and the ethylene oxide/propylene oxide derivative thereof.
3. The immersion fluid of claim 1 wherein the at least one additive comprises at least one selected from the alkyl alcohol, the alkyl ethoxylate, and the alkyl propoxylate and derivatives thereof.
4. The immersion fluid of claim 1 wherein the at least one additive comprises the glucamine derivative of a glycidyl ether wherein the glucamine derivative comprises at least one selected from the alkyl amine, the alkyl diamine, the alkyl alcohol, and the acetylenic alcohol.
5. The immersion fluid of claim 1 wherein the salt comprises at least one selected from a metal salt, an ammonium salt, a sulfonium salt, a phosphonium salt, a halide salt, a sulfate salt, a sulfide salt, a sulfonate salt, a sulfite salt, a phosphate salt, a phosphonate salt, a phosphite salt, and combinations thereof.
6. The immersion fluid of claim 1 wherein the at least one additive comprises a siloxane-containing compound that is at least one selected from a polysiloxane, a poly(dimethyl)siloxane, a polysiloxane polyester copolymer, and combinations thereof.
7. An immersion fluid having a transmission of 50% or greater at an operating wavelength ranging from 140 nm to 365 nm, the immersion fluid comprising:

at least one carrier medium selected from the group consisting of an aqueous fluid, a non-aqueous fluid, and mixtures thereof wherein the at least one carrier medium has a refractive index greater than or equal to water at the operating wavelength; and

about 1 ppm to a maximum solubility limit of at least one additive selected from an alkyl alcohol; an alkyl ethoxylate, an alkyl propoxylate, and derivative thereof; an alkyl acid ester; an alkyl amine comprising an amine group; an alkyl amine ethoxylate; an acetylenic alcohol, an acetylenic diol, and ethylene oxide/propylene

oxide derivatives thereof; an alkyl polyglycoside; a block oligomer; a polymer of ethylene and propylene oxide; a glycidyl ether; a glucamine derivative of a glycidyl ether; an urea; a siloxane-containing compound; a fluorinated or partially fluorinated acetylenic alcohol, diol and derivatives thereof; a fluorosurfactant; an ionic liquid; a salt; and an electrolyte, provided that if the at least one additive is a fluorosurfactant then the immersion fluid comprises about 1 % by weight or greater of an aqueous fluid.

8. The immersion fluid of claim 7 wherein the immersion fluid exhibits a dynamic surface tension of about 55 dynes/cm² or less at 23°C and 1 bubble/second according to the maximum-bubble-pressure method.
9. The immersion fluid of claim 7 wherein the immersion fluid exhibits a contact angle of about 50° or less at 30 seconds.
10. The immersion fluid of claim 7 wherein the immersion fluid exhibits a specific absorbance of 0.5 cm⁻¹ or less at an operating wavelength of 193 nm.
11. The immersion fluid of claim 7 wherein the at least one carrier medium is the mixture of the aqueous and the non-aqueous fluids.
12. The immersion fluid of claim 11 wherein the non-aqueous fluid is at least one selected from methanol, ethanol, isopropyl alcohol, glycerol, ethylene glycol and derivatives thereof, polyethylene glycol and derivatives thereof, and tetrahydrofuran.
13. An immersion fluid having a transmission of 50% or greater at an operating wavelength ranging from 140 nm to 365 nm comprising: at least one carrier medium selected from an aqueous fluid, a non-aqueous fluid and a mixture of the non-aqueous fluid and the aqueous fluid wherein the at least one carrier medium has a refractive index greater than or equal to water at the operating wavelength and wherein if the at least one carrier medium is the mixture then the non-aqueous fluid is water miscible.
14. The immersion fluid of claim 13 further comprising from 1 ppm to a maximum solubility limit of an alkyl alcohol; an alkyl ethoxylate, an alkyl propoxylate, and derivative thereof; an alkyl acid ester; an alkyl amine comprising an amine group; an alkyl amine ethoxylate; an acetylenic alcohol, an acetylenic diol, and ethylene oxide/propylene oxide derivatives thereof; an alkyl polyglycoside; a block oligomer; a polymer of ethylene and propylene oxide; a glycidyl ether; a glucamine derivative of a glycidyl ether; an urea; a siloxane-containing compound; a fluorinated or partially fluorinated acetylenic alcohol, diol and derivatives thereof; a fluorosurfactant; an ionic liquid; a salt; and an electrolyte, provided that if the at least one additive is a fluorosurfactant then the immersion fluid comprises about 1 % by weight or greater of an aqueous fluid.
15. The immersion fluid of claim 13 wherein the non-aqueous fluid comprises a non-aqueous fluid that is at least one selected from citric acid, bicyclohexyl, glycerol, dodecane, cyclohexane, decalin, octane, and cis-2-methylcyclohexanol.

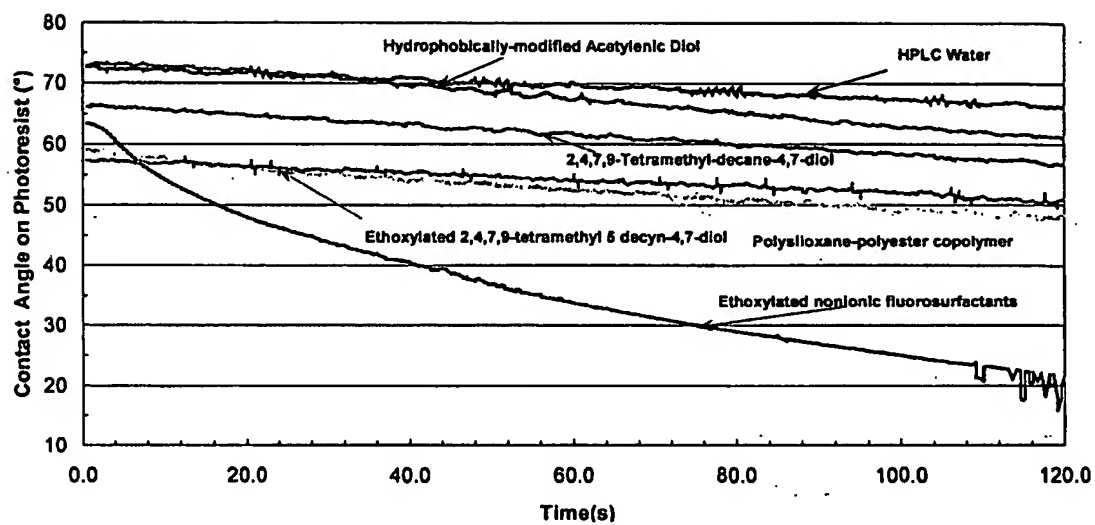


Figure 1

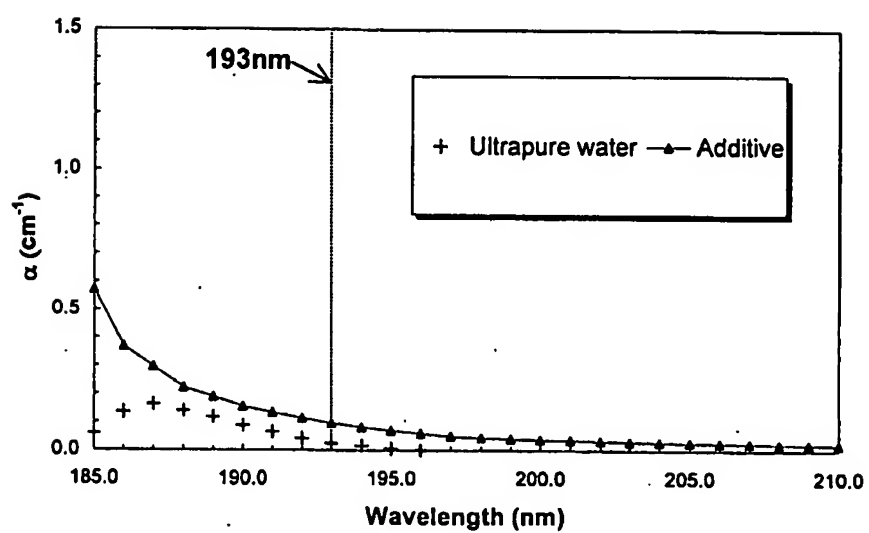


Figure 2

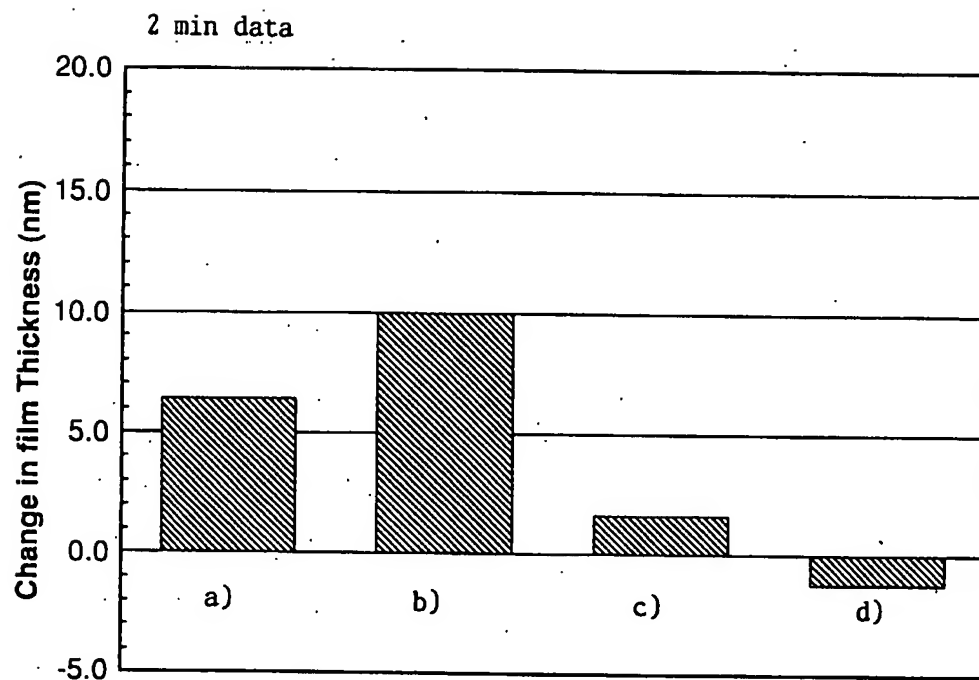


Figure 3

- a) dimethyl-4-heptanol
- b) hydrophobically modified acetylenic diol
- c) ultra pure water
- d) ethyloxylated non-ionic fluorosurfactant

Figure 4. Absolute Refractive index of Immersion Fluids @ 193nm

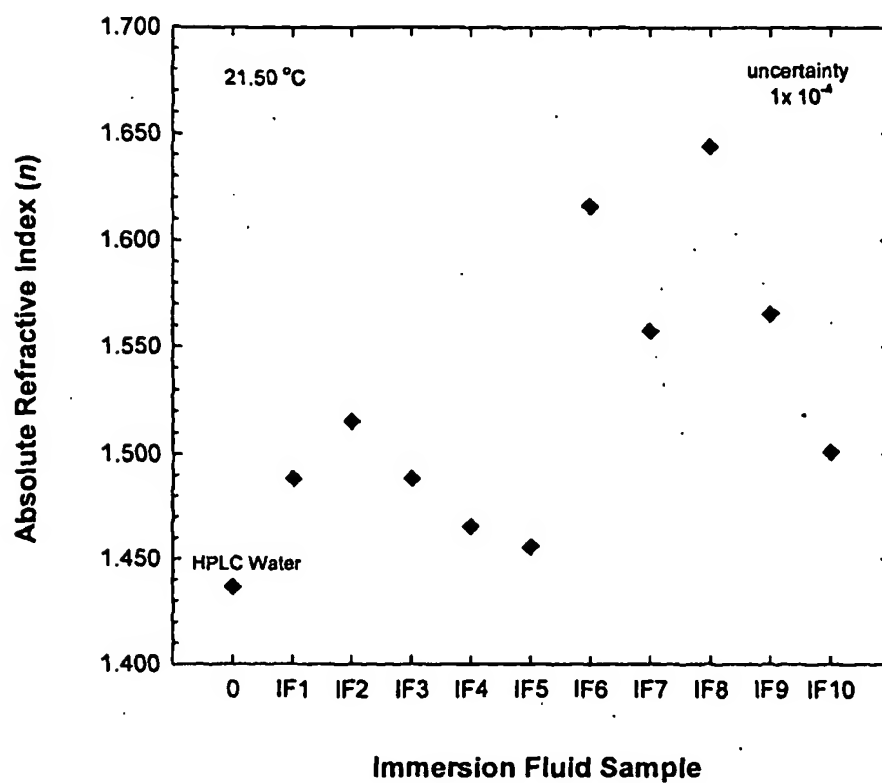
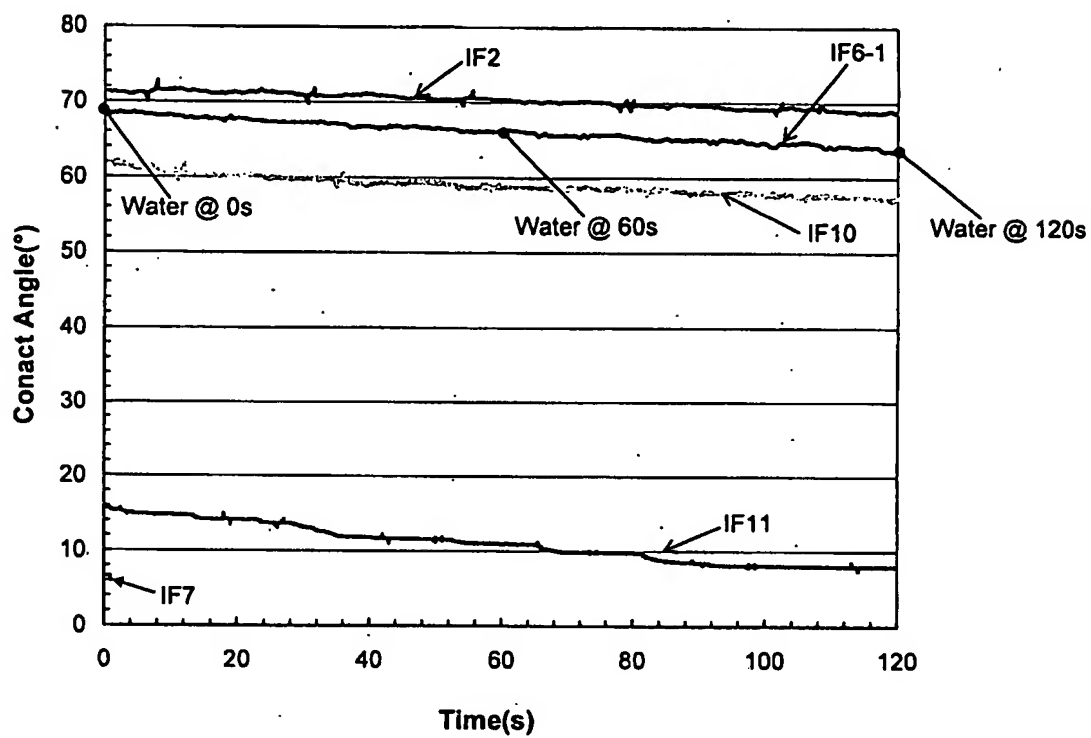


Figure 5

Dynamic Contact Angle Measurements of Immersion Fluids on unexposed
193nm Photoresist





(11) **EP 1 557 721 A3**

(12) **EUROPEAN PATENT APPLICATION**

(88) Date of publication A3:
06.06.2007 Bulletin 2007/23

(51) Int Cl.:
G03F 7/20 (2006.01)

(43) Date of publication A2:
27.07.2005 Bulletin 2005/30

(21) Application number: **05000989.3**

(22) Date of filing: **19.01.2005**

(84) Designated Contracting States:
**AT BE BG CH CY CZ DE DK EE ES FI FR GB GR
HU IE IS IT LI LT LU MC NL PL PT RO SE SI SK TR**
Designated Extension States:
AL BA HR LV MK YU

- **Budhlall, Bridgette Marla**
Bethlehem, PA 18018 (US)
- **Parris, Gene Everad**
Coopersburg, PA 18036 (US)
- **Barber, Leslie Cox**
Cave Creek, AZ 85331 (US)

(30) Priority: **23.01.2004 US 764227**
07.01.2005 US 30132

(74) Representative: **Schwabe - Sandmair - Marx**
Patentanwälte
P.O. Box 86 02 45
81629 München (DE)

(71) Applicant: **AIR PRODUCTS AND CHEMICALS, INC.**
Allentown, PA 18195-1501 (US)

(72) Inventors:
• **Zhang, Peng**
Quakertown, PA 18951 (US)

(54) **Immersion lithography fluids**

(57) Suitable additives that may be added into immersion fluids, immersion fluids comprising at least one carrier medium selected from an aqueous fluid, a non-aqueous fluid, and mixtures thereof, and immersion fluids comprising at least one carrier medium and at least

one additive useful for performing immersion lithography at an operating wavelength ranging from 140 nm to 365 nm are disclosed herein.

EP 1 557 721 A3



European Patent
Office

EUROPEAN SEARCH REPORT

Application Number
EP 05 00 0989

DOCUMENTS CONSIDERED TO BE RELEVANT			
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (IPC)
X	RU 2 051 940 C1 (PROIZV OB EDINENIE NOVOSIB PRI [RU]) 10 January 1996 (1996-01-10) * column 1, lines 12-34; claims 1,2; table 1 *	1-15	INV. G03F7/20
X	SU 1 204 623 A1 (UNIV NOVOSIBIRSKY [SU]; INST TEPILOFIZIKI SO AN SSSR [SU]) 15 January 1986 (1986-01-15) * column 1, lines 9-18; table 1 *	1-15	
X	SU 948 994 A1 (INST TEPILOFIZIKI SO AN SSSR [SU]; UNIV NOVOSIBIRSKY [SU]) 7 August 1982 (1982-08-07) * column 1, line 15 - column 2, line 4; table 1 *	1-15	
X	WO 03/077034 A (DU PONT [US]; FRENCH ROGER HARQUAIL [US]; JONES DAVID JOSEPH [US]; WHE) 18 September 2003 (2003-09-18) * page 10, lines 1-36; claims 1-4,17,32; table 1 *	1-15	
Y	JP 10 340846 A (NIPPON KOGAKU KK) 22 December 1998 (1998-12-22) * paragraphs [0026] - [0032]; figures 1-3 *	1-15	TECHNICAL FIELDS SEARCHED (IPC)
Y	WO 99/01797 A (BATCHELDER JOHN SAMUEL [US]) 14 January 1999 (1999-01-14) * table 1 *	1-15	G03F
Y	EP 0 063 684 A (HOFFMANN LA ROCHE [CH]) 3 November 1982 (1982-11-03) * claim 1 *	1-15	
		-/--	
The present search report has been drawn up for all claims			
Place of search Munich		Date of completion of the search 26 April 2007	Examiner Thiele, Norbert
<p>CATEGORY OF CITED DOCUMENTS</p> <p>X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document</p> <p>T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons & : member of the same patent family, corresponding document</p>			

1
EPO FORM 1503 (03.02) (P04C01)



European Patent
Office

EUROPEAN SEARCH REPORT

Application Number
EP 05 00 0989

DOCUMENTS CONSIDERED TO BE RELEVANT			
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (IPC)
A	US 4 480 910 A (TAKANASHI AKIHIRO [JP] ET AL) 6 November 1984 (1984-11-06) * claim 1 *	1-15	
E	WO 2005/050324 A (DSM IP ASSETS BV [NL]; JAHROMI SHAHAB [NL]; WIENKE DIETRICH [NL]; BREM) 2 June 2005 (2005-06-02) * page 2, line 28 - page 3, line 21; claims 1-4 *	1-15	
E	WO 2005/074606 A (ROCHESTER INST OF TECHNOLOGY [US]) 18 August 2005 (2005-08-18) * paragraphs [0040] - [0043]; claims 1-5 *	1-15	
E	WO 2006/045748 A (ZEISS CARL SMT AG [DE]; WEIPPERT HANS-JOACHIM [DE]; SCHUSTER KARL-HEIN) 4 May 2006 (2006-05-04) * claims 1,17-28,45,46,84-86 *	1-15	
			TECHNICAL FIELDS SEARCHED (IPC)
The present search report has been drawn up for all claims			
Place of search Munich		Date of completion of the search 26 April 2007	Examiner Thiele, Norbert
<p>CATEGORY OF CITED DOCUMENTS</p> <p>X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document</p> <p>T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons & : member of the same patent family, corresponding document</p>			

1
EPO FORM 1503 03 82 (P04C01)

**ANNEX TO THE EUROPEAN SEARCH REPORT
ON EUROPEAN PATENT APPLICATION NO.**

EP 05 00 0989

This annex lists the patent family members relating to the patent documents cited in the above-mentioned European search report.
The members are as contained in the European Patent Office EDP file on
The European Patent Office is in no way liable for these particulars which are merely given for the purpose of information.

26-04-2007

Patent document cited in search report	Publication date	Patent family member(s)	Publication date
RU 2051940 C1	10-01-1996	NONE	
SU 1204623 A1	15-01-1986	NONE	
SU 948994 A1	07-08-1982	NONE	
WO 03077034 A	18-09-2003	AU 2003218015 A1 CN 1747917 A EP 1480929 A2 JP 2005519346 T	22-09-2003 15-03-2006 01-12-2004 30-06-2005
JP 10340846 A	22-12-1998	JP 3817836 B2	06-09-2006
WO 9901797 A	14-01-1999	US 5900354 A	04-05-1999
EP 0063684 A	03-11-1982	GB 2097395 A US 4493533 A	03-11-1982 15-01-1985
US 4480910 A	06-11-1984	CA 1159160 A1 DE 3272511 D1 EP 0060729 A2 JP 1501475 C JP 57153433 A JP 63049893 B	20-12-1983 18-09-1986 22-09-1982 28-06-1989 22-09-1982 06-10-1988
WO 2005050324 A	02-06-2005	NONE	
WO 2005074606 A	18-08-2005	EP 1723467 A2	22-11-2006
WO 2006045748 A	04-05-2006	NONE	

EPO FORM P0459

For more details about this annex : see Official Journal of the European Patent Office, No. 12/82